

Docket No.: 00131-00422-US  
(PATENT)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

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In re Patent Application of:  
John F. Rabolt et al.

Application No.: National Phase of US05/08414

Confirmation No.: N/A

Filed: Concurrently Herewith

Art Unit: N/A

For: **ACTIVE AND ADAPTIVE  
PHOTOCHROMIC FIBERS, TEXTILES  
AND MEMBRANES**

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Examiner: Not Yet Assigned

**INFORMATION DISCLOSURE STATEMENT (IDS)**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

Pursuant to 37 CFR 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached PTO/SB/08. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement accompanies the new patent application submitted herewith.

Copies of the references on the PTO/SB/08 are not provided.

The Director is hereby authorized to charge any deficiency in the fees filed, asserted to be filed or which should have been filed herewith (or with any paper hereafter filed in this

Application No.: National Phase of US05/08414

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application by this firm) to our Deposit Account No. 03-2775, under Order No. 00131-00422-US.

Respectfully submitted,

By 

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Under the Paperwork Reduction Act of 1995, no persons are required to respond to a collection of information unless it contains a valid OMB control number.

Substitute for form 1449A/B/PTO  <b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b>  <i>(Use as many sheets as necessary)</i>				<b>Complete if Known</b>	
				Application Number	Not Yet Assigned
				Filing Date	Concurrently Herewith
				First Named Inventor	John F. Rabolt
				Art Unit	N/A
				Examiner Name	Not Yet Assigned
				Attorney Docket Number	00131-00422-US
Sheet	1	of	2		

U.S. PATENT DOCUMENTS					
Examiner Initials*	Cite No. <sup>1</sup>	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number-Kind Code <sup>2</sup> (if known)			
	AA*	US-4,323,525	04-06-1982	Bornat	
	AB*	US-4,689,525	08-25-1987	Shimoma et al.	
	AC*	US-5,213,733	05-25-1993	Hwu et al.	
	AD*	US-5,422,181	06-06-1995	Hwu et al.	
	AE*	US-5,821,287	10-13-1998	Hu et al.	
	AF*	US-20010045547-A1	11-29-2001	Senecal et al.	
	AG*	US-20020084178-A1	07-04-2002	Dubson et al.	
	AH*	US-20020100725-A1	08-01-2002	Lee et al.	
	AI*	US-6,440,340	08-27-2002	Smith et al.	
	AJ*	US-20020175449-A1	11-28-2002	Chu et al.	
	AK*	US-20020188043-A1	12-12-2002	Kim et al.	
	AL*	US-20030021792-A1	01-30-2003	Roben et al.	
	AM*	US-20030099910-A1	05-29-2003	KIM et al.	
	AN*	US-20030106294-A1	06-12-2003	Chung et al.	
	AO*	US-20030130456-A1	07-10-2003	Kim et al.	
	AP*	US-2003/0137069	07-24-2003	Reneker	
	AQ*	US-20030168756-A1	09-11-2003	Balkus et al.	
	AR*	US-20030174560-A1	09-18-2003	Dahmen et al.	
	AS*	US-20030195611-A1	10-16-2003	Greenhalgh et al.	
	AT*	US-20030213942-A1	11-20-2003	Kim et al.	
	AU*	US-20030215624-A1	11-20-2003	Layman et al.	
	AV*	US-20040018226-A1	01-29-2004	Wnek et al.	
	AW*	US-6,695,992	02-24-2004	Reneker	
	AX*	US-20040037813-A1	02-26-2004	Simpson et al.	
	AY*	US-20040038014-A1	02-26-2004	Schaefer et al.	
	AZ*	US-20040013873-A1	09-14-2004	Wendorff et al.	

  

FOREIGN PATENT DOCUMENTS						
Examiner Initials*	Cite No. <sup>1</sup>	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T <sup>6</sup>
		Country Code <sup>3</sup> -Number <sup>4</sup> -Kind Code <sup>5</sup> (if known)				

\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. \* CITE NO.: Those application(s) which are marked with an single asterisk (\*) next to the Cite No. are not supplied (under 37 CFR 1.98(a)(2)(iii)) because that application was filed after June 30, 2003 or is available in the IFW. <sup>1</sup> Applicant's unique citation designation number (optional). <sup>2</sup> See Kinds Codes of USPTO Patent Documents at [www.uspto.gov](http://www.uspto.gov) or MPEP 901.04. <sup>3</sup> Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). <sup>4</sup> For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. <sup>5</sup> Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. <sup>6</sup> Applicant is to place a check mark here if English language Translation is attached.

NON PATENT LITERATURE DOCUMENTS			
Examiner Initials	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T <sup>2</sup>

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Examiner Signature		Date Considered	
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